

United States Patent and Trademark Office

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.usplo.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/056,579	01/25/2002	Mohamed S. Hamed	CAEP:101_US_	4685	
24041	7590 11/02/2004		EXAMINER		
SIMPSON & SIMPSON, PLLC 5555 MAIN STREET			PHAM, MINH CHAU THI		
	YILLE, NY 14221-5406		ART UNIT	PAPER NUMBER	
			1724		
		•	DATE MAILED: 11/02/200-	4	

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)	
		10/056,579	HAMED ET AL.	
	Office Action Summary	Examiner	Art Unit	
		Minh-Chau T. Pham	1724	
Period fo	The MAILING DATE of this communication app	ears on the cover sheet with	the correspondence address	s
A SH THE - Exte after - If the - If NC - Failu Any	IORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. To period for reply specified above is less than thirty (30) days, a reply operiod for reply is specified above, the maximum statutory period vare to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing ted patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a rep y within the statutory minimum of thirty (will apply and will expire SIX (6) MONTH cause the application to become ABA	ly be timely filed 30) days will be considered timely. 35 from the mailing date of this commun	nication.
Status	•			
1) 🛛	Responsive to communication(s) filed on 16 Au	ugust 2004		
		action is non-final.		
3)	,		s, prosecution as to the mer	its is
: 	closed in accordance with the practice under E			
Dispositi	ion of Claims			
	Claim(s) <u>1-10</u> is/are pending in the application.			
	4a) Of the above claim(s) is/are withdray	vn from consideration.		
	Claim(s) is/are allowed.			
	Claim(s) <u>1-10</u> is/are rejected.			
	Claim(s) is/are objected to.		•	
8)[]	Claim(s) are subject to restriction and/or	election requirement.		
Applicati	on Papers			
9)[The specification is objected to by the Examiner	r.		
	The drawing(s) filed on is/are: a) acce		the Examiner	
,—	Applicant may not request that any objection to the			
	Replacement drawing sheet(s) including the correcti			124(4)
11)	The oath or declaration is objected to by the Ex			
		armior. Note the attached C	omec Added of John 1 10-10	12.
Priority u	ınder 35 U.S.C. § 119			
12) 🗌	Acknowledgment is made of a claim for foreign	priority under 35 U.S.C. § 1	19(a)-(d) or (f).	
a)[☐ All b)☐ Some * c)☐ None of:			
	1. Certified copies of the priority documents	have been received.		
	2. Certified copies of the priority documents	have been received in App	lication No	
•	3. Copies of the certified copies of the priori	ity documents have been re	ceived in this National Stage	Э
	application from the International Bureau		_	
* S	see the attached detailed Office action for a list of	of the certified copies not re	ceived.	
A44a=t-	W-1			
Attachment	• •	 1		
	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948)	4) [_] Interview Sun Paper No/s//N	nmary (PTO-413) /ail Date	
	nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08)		mal Patent Application (PTO-152)	
Paper	No(s)/Mail Date	6) Other:		
S. Patent and Tr. PTOL-326 (Re	4.64	ion Summary	Part of Paper No./Mail Date	e 1028

Art Unit: 1724

Claim Rejections - 35 USC § 103

The text of those sections of Title 35, U.S. Code not included in this action can be found in a prior Office action.

Claims 1-10 are <u>again</u> rejected under 35 U.S.C. 103(a) as being unpatentable over Durdag et al (6,193,774 B1).

Durdag el al disclose an apparatus for removal particulates located in an air stream in a thermal oven (col. 1, lines 7-10) comprising means to move air in the thermal oven (10) and a plurality of particulate removal members (100, 102, 104 & 106) secured to the inside wall (44) of the thermal oven and the members (100, 102, 104 & 106) projecting into the air stream (col. 4, lines 21-24). Each removal member comprises two planar members (100 & 102 in Fig. 6) to form a "V" shaped where the structure includes a vertex (col. 4, lines 34-37) pointing generally in the direction of the air stream (see 100 and 102 against the arrow air flow in Fig. 4), and the angles of the planar members range from 40 degrees to greater than 90 degrees (col. 4, lines 51 and 64). It would have been obvious to a person having ordinary skill in the art at the time the invention was made to provide removal members in a thermal oven as taught by Durdag et al since the thermal oven with an oven gas decontamination system such as removal members or baffles would reduce fouling of the convection oven components and surfaces.

Response to Arguments

Applicant's arguments filed on August 16, 2004 have been fully considered but they are not persuasive.

Art Unit: 1724

Applicant argues that "Durdag discloses decontamination baffles for removing gaseous contaminants, not particulate matter" and "fails to disclose the sand removal members in an air stream in a thermal sand removal oven". The Examiner respectfully disagrees. Durdag et al reference to show a closed loop oven apparatus for removal particulates located in an air stream in a thermal oven (col. 1, lines 7-10) comprising means to move air in the thermal oven (10) and a plurality of particulate removal members (100, 102, 104 & 106) secured to the inside wall (44) of the thermal oven and the members (100, 102, 104 & 106) projecting into the air stream (col. 4, lines 21-24). Each removal member comprises two planar members (100 & 102 in Fig. 6) to form a "V" shaped where the structure includes a vertex (col. 4, lines 34-37) pointing generally in the direction of the air stream (see 100 and 102 against the arrow air flow in Fig. 4), and the angles of the planar members range from 40 degrees to greater than 90 degrees (col. 4, lines 51 and 64). It would have been obvious to a person having ordinary skill in the art at the time the invention was made to provide removal members in a thermal oven as taught by Durdag et al since the thermal oven with an oven gas decontamination system such as removal members or baffles would reduce fouling of the convection oven components and surfaces, as claimed. Durdag does disclose a decontamination baffles for removing contaminants. "Contaminant" is defined as "intrusion or contact with dirt or foulness from an outside source" (definition from the Webster's Ninth New Collegiate Dictionary by Merriam-Webster, 1991, page 283). Therefore, contaminant is clearly particulates like dirt or any others such as gaseous materials. So Durdag discloses a decontamination baffles which can remove

Art Unit: 1724

contaminants such as particulates such as dirt or gaseous materials. Per Applicant's argument that "Durdag fails to disclose the sand removal members in an air stream in a thermal sand removal oven", the recitation of "removal sand in a thermal sand removal oven" has not been given patentable weight because it has been held that a preamble is denied the effect of a limitation where the claim is drawn to a structure and the portion of the claim following the preamble is a self-contained description of the structure not depending for completeness upon the introductory clause. See Kropa v. Robie, 88
USPQ 478 (CCPA 1951).

Applicant's arguments with respect to claims 1-10 have been thoroughly considered but are moot in view of the rejection, as discussed above.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Minh-Chau T. Pham whose telephone number is (571) 272-1163. The examiner can normally be reached on Mon/Tues/Thur/Fri 7:00 am - 5:30 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Duane Smith can be reached on (571) 272-1166. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Art Unit: 1724

Page 5

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Minh-Chau Pham Patent Examiner

Art Unit: 1724 October 28, 2004